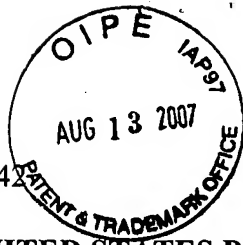


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ITW

Docket No.: 070759-0042

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
Yasuhiro WATANABE, et al.	:	Confirmation Number: 4678
Application No.: 10/575,899	:	Group Art Unit: 2814
Filed: April 14, 2006	:	Examiner: Long Pham
For: SEMICONDUCTOR LASER DEVICE AND MANUFACTURING METHOD THEREOF		

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 11, 2007, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.